

10/20/03

Sheet 1 of 1

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. 132913-1	SERIAL NO.	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <b><u>LIST OF ITEMS</u></b>				Applicant: Larry Neil Lewis et al.		
				Filing Date	Group	
<b>U.S. PATENT DOCUMENTS</b>						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CJL	A1 4,681,963	7/21/87	Lewis	556	453	
CJL	A2 4,705,765	11/10/87	Lewis	502	152	
CJL	A3 6,515,314	2/4/03	Duggal et al.	257	184	
CJL	A4 5,696,384	12/9/97	Ogi et al.	852	182.12	
CJL	A5 5,789,027	8/4/98	Watkins et al.	427	250	
CJL	A6 5,783,716	7/21/98	Baum et al.	596	136	
CJL	A7 6,204,178	3/20/01	Marsh	438	686	
CJL	A8 6,387,802	5/14/02	Marsh	438	686	
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
B1						
B2						
B3						
<b>OTHER INFORMATION</b> (Including Author, Title, Date, Pertinent Pages, etc.)						
LM	C1	NH Dryden et al., "Chemical Vapor Deposition of Platinum: New Precursors and Their Properties", American Chemical Society, Chem. Material, Volume 3, pp 677-685, 1991.				
CJL	C2	J-C Hierso et al., "Platinum and Palladium Films Obtained by Low-Temperature MOCVD for the Formation of Small Particles on Divided Supports as Catalytic Materials", Chem. Material, Volume 12, pp. 390-399, 2000.				
CJL	C3	Z. Xue et al., Characterization of (Methylcyclopentadienyl)trimethylplatinum and Low-Temperature Organometallic Chemical Vapor Deposition of Platinum Metal", J. Am. Chem. Soc, Volume 111, pp. 8779-8784, 1989.				
CJL	C4	LN Lewis et al., "Mechanism of Formation of Platinum (O) Complexes Containing Silicon – Vinyl Ligands", Organometallics, Volume 14, pp. 2202-2213, 1995.				
CJL	C5	R. Kumar et al, "New Precursors for Chemical Vapour Deposition of Platinum and the Hydrogen Effect on CVD", Polyhedron, Volume 8, No. 4, pp. 551-553, 1989.				
CJL	C6	HD Kaesz et al., Low-Temperature Organometallic Chemical Vapor Deposition of Transition Metals", Mat. Res. Soc. Symp. Proc., Volume 131, pp. 395-401, 1989.				
CJL	C7	Copending US Application Serial No. 10/316,317 (Docket 125159-1), filed December 12, 2002, by James Lawrence Spivack et al., entitled "STRUCTURED DYE SENSITIZED SOLAR CELL".				
CJL	C8	Copending US Application Serial No. 10/316,318 (Docket 125120-1), filed December 12, 2002, by James Lawrence Spivack et al., entitled "DYE SENSITIZED SOLAR CELLS HAVING FOIL ELECTRODES".				
CJL	C9	Copending US Application Serial No. 10/425,901 (Docket 120198-1-1), filed April 29, 2003, by Anil Raj Duggal et al., entitled "LIGHT SOURCE WITH ORGANIC LAYER AND PHOTOLUMINESCENT LAYER".				
EXAMINER <i>CJL</i>				DATE CONSIDERED <i>3/13/06</i>		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
132913-1SERIAL NO.  
10/689,792INFORMATION DISCLOSURE STATEMENT BY APPLICANT  
LIST OF ITEMSApplicant  
Larry Neil Lewis et al.Filing Date  
10/20/03

Group Art Unit

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A1						
A2						
A3						
A4						

## FOREIGN PATENT DOCUMENTS

CNR	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	YES	NO
						X	X	X
CNR	B1	JP20002231657	8/16/02	Japan (Abstract)			X	
CNR	B2	JP 8020870	1/23/96	Japan (Abstract)			X	
CNR	B3	JP 2800686	1/23/96	Japan (Abstract)			X	

## OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

C1	
C2	
C3	
C4	
C5	
C6	
C7	
C8	

EXAMINER

*O/NL*

DATE CONSIDERED

*3/13/06*

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